

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1501	(438/151).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; IBM_TDB	OR	OFF	2006/10/27 16:17
L2	1378	(438/303).CCLS.	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	OFF	2006/10/27 16:29
L3	6936	((257/61,66,344,408,900,E21.435, E29.278) or (438/306,595)).CCLS.	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	OFF	2006/10/27 16:31
L4	3751	(L1 L2 L3) and (LDD (lightly adj doped adj drain))	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 17:08
L5	511	L4 and (taper\$4)	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 16:43
L6	481	L5 and (@ad<"20040419" @rlad<"20040419")	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 17:09
L7	468	L6 and ((insulat\$3 dielectric) adj (layer film))	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 16:47
L8	153	L6 and (second adj (insulat\$3 dielectric) adj (layer film))	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 16:50
L9	48	(L1 L2 L3) and (endpoint near5 detect\$3)	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 17:55
L10	45	L9 and (@ad<"20040419" @rlad<"20040419")	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 17:56
L11	21	L10 and (wet near3 etch\$3)	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 17:27
L12	2638	(L1 L2 L3) and (((insulator insulating dielectric) near4 gate) same nitride)	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 17:56

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L13	2441	L12 and (@ad<"20040419" @rlad<"20040419")	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 17:57
L14	1815	(L1 L2 L3) and (((insulator insulating dielectric) near4 gate) with nitride)	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 17:56
L15	1675	L14 and (@ad<"20040419" @rlad<"20040419")	US-PGPUB; USPAT; EPO; JPO; IBM_TDB	OR	ON	2006/10/27 17:57